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Application/Control No.	Applicant(s)/Patent under Reexamination						
10/735,943	CHEN ET AL.						
Examiner	Art Unit						
Adi Amrany	2836						

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INTERFERENCE SEARCHED								
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307	116	10/17/2006	AA					
	l interference arch	10/17/2006	AA					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)								
	DATE	EXMR						
see updated search history	10/17/2006	AA						